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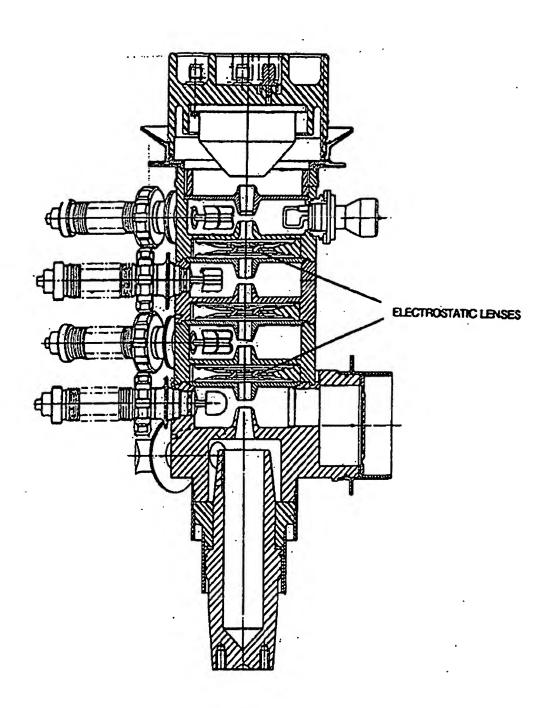


FIG. 1 (Prior Art)

Replacement Sheet
Title: HINGED STRUCTURES FOR VACUUM MICROELECTRONICS AND METHODS OF MANUFACTURING SAME
Inventor: Sadwick et al.
Application No. 10/775,266

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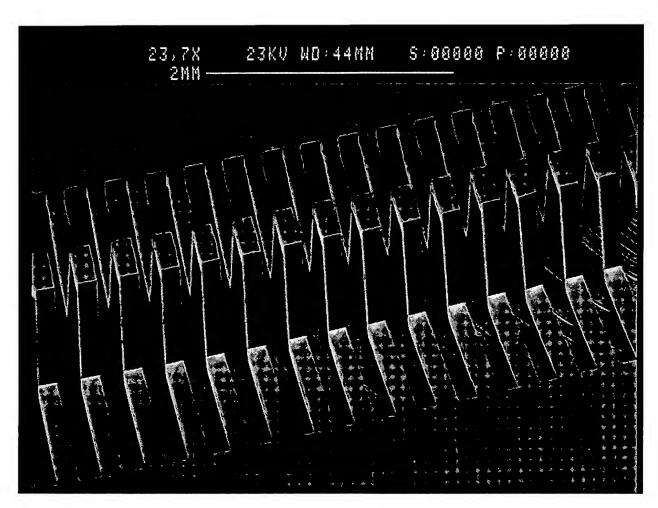
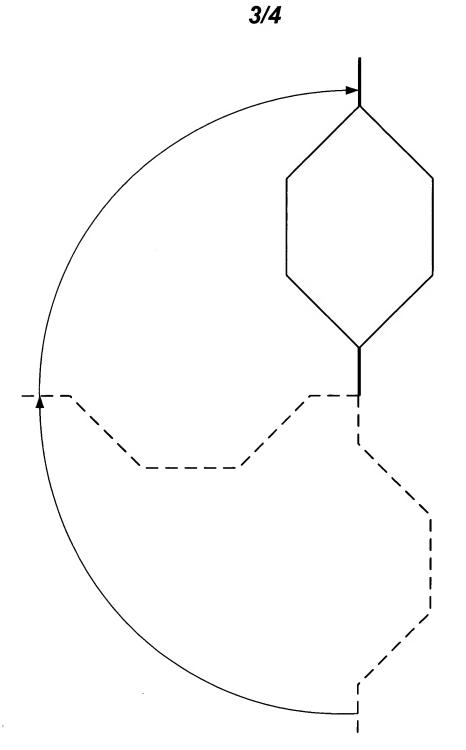


FIG. 2



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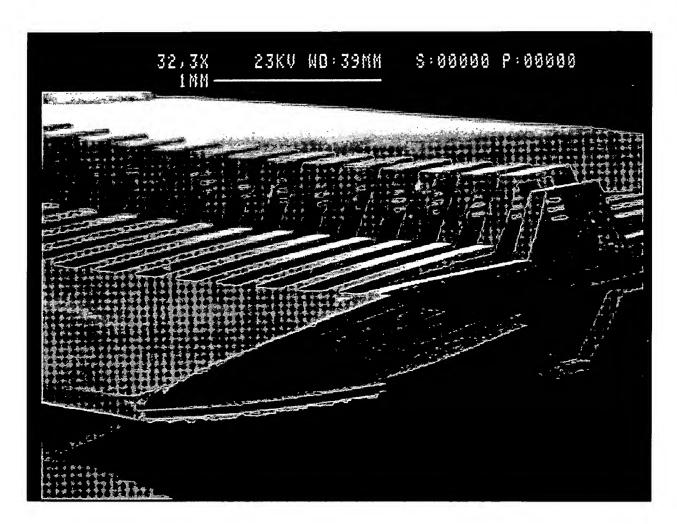


FIG. 4